



US00D341787S

**United States Patent** [19]  
**Chan**

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[54] **INFRARED SENSOR**

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[73] **Assignee: Ascentex Industry Corporation, Taipei, Taiwan**

[\*\*] **Term: 14 Years**

[21] **Appl. No.: 892,511**

[22] **Filed: Jun. 2, 1992**

[52] **U.S. Cl. .... D10/106**

[58] **Field of Search ..... D13/158; D10/106; 250/221, 341**

[56] **References Cited**

**U.S. PATENT DOCUMENTS**

- D. 312,053 11/1990 Jacobs et al. .... D10/106
- D. 335,467 5/1993 Cheng ..... D10/106
- 5,103,346 4/1992 Chang ..... 250/221 X

**OTHER PUBLICATIONS**

Leviton passive infrared motion sensor on p. 43 of *Electrical Construction & Maintenance* Dec. 1989.

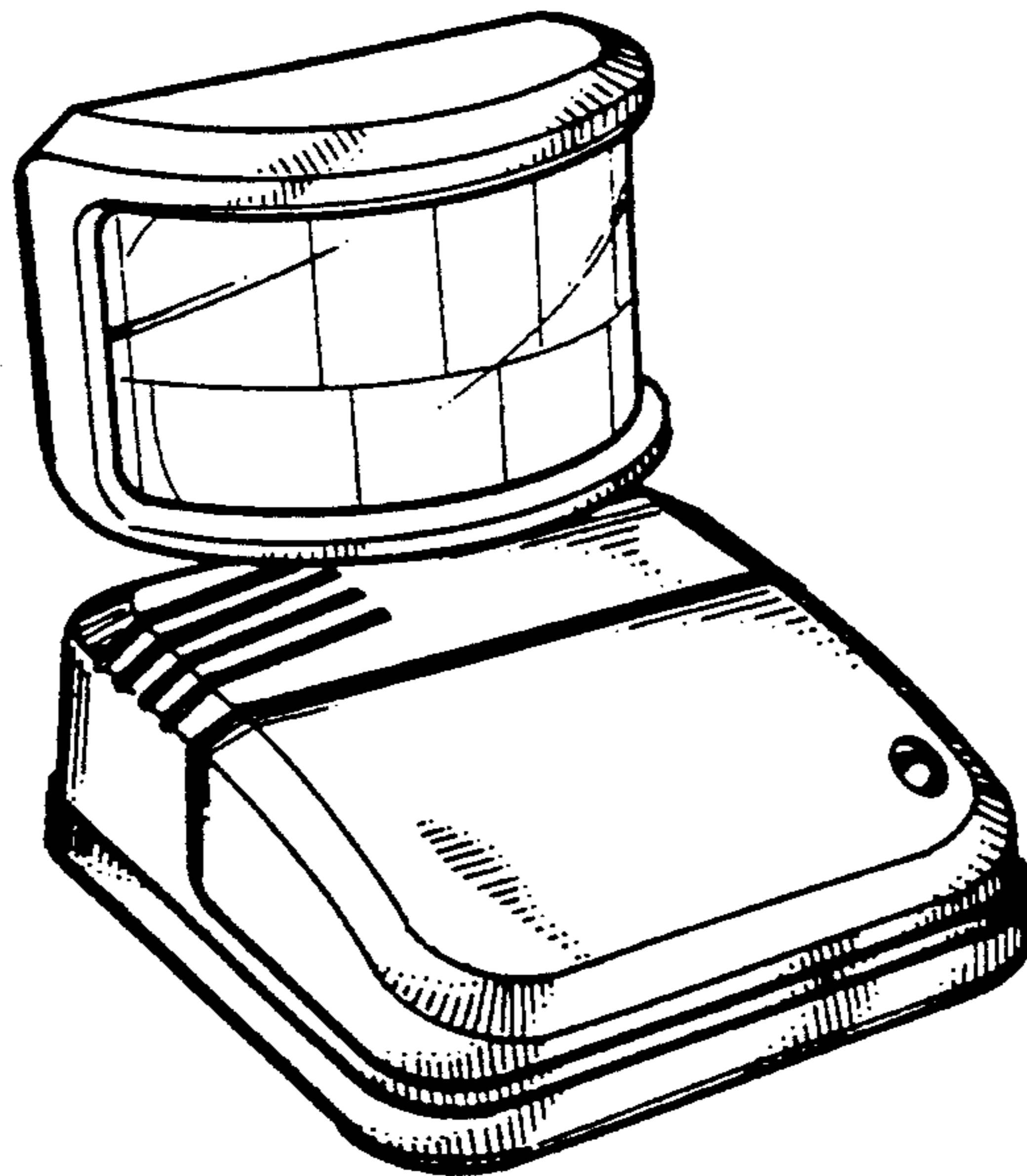
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*Attorney, Agent, or Firm*—Poms, Smith, Lande & Rose

[57] **CLAIM**

The ornamental design for an infrared sensor, as shown and described.

**DESCRIPTION**

FIG. 1 is a perspective view from the front, left, and top side of an infrared sensor showing my design; FIG. 2 is a front elevational view thereof; FIG. 3 is a left side elevational view thereof; FIG. 4 is a right side elevational view thereof; FIG. 5 is a top plan view thereof; FIG. 6 is a bottom plan view thereof; and, FIG. 7 is a rear elevational view thereof.



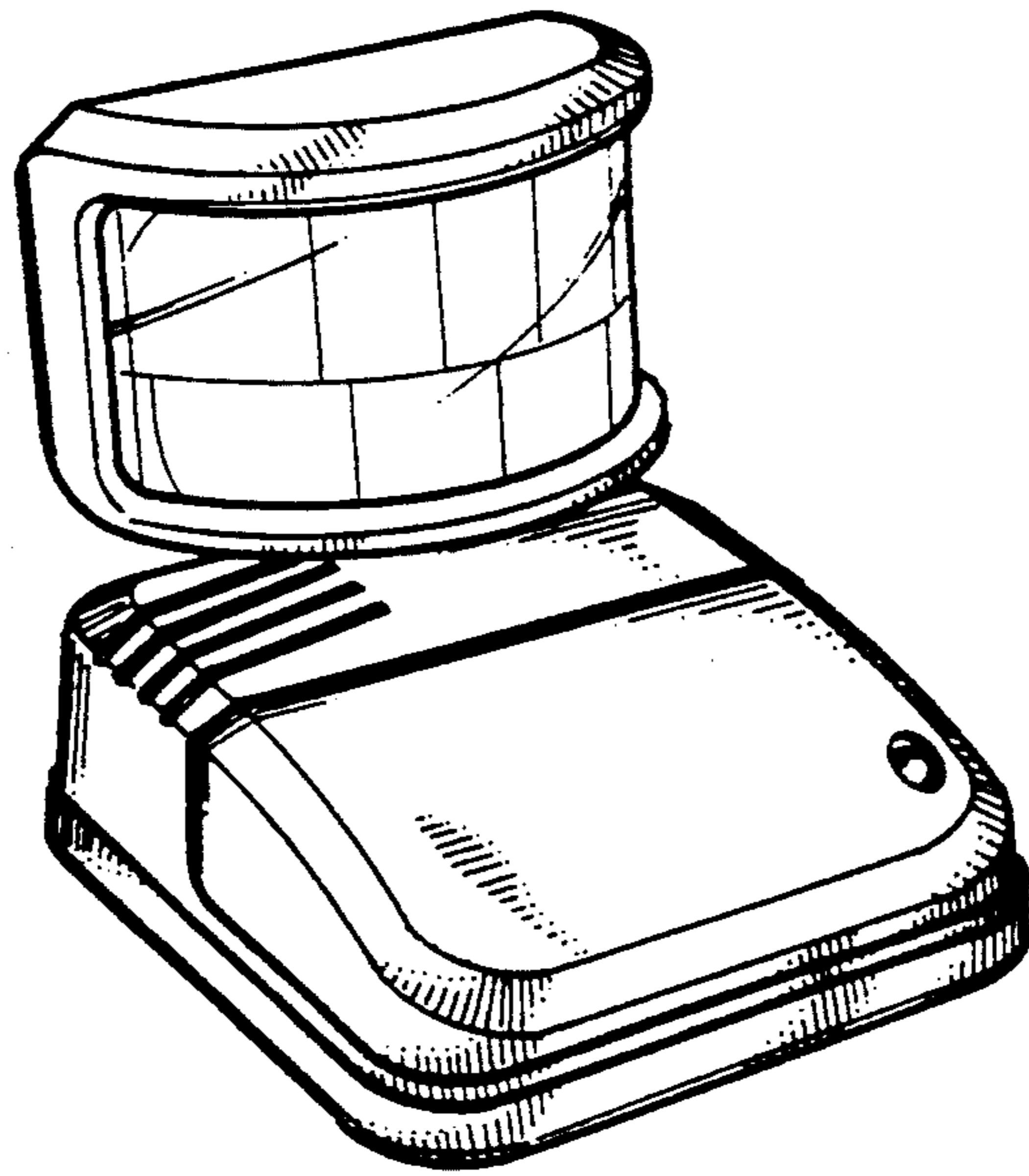
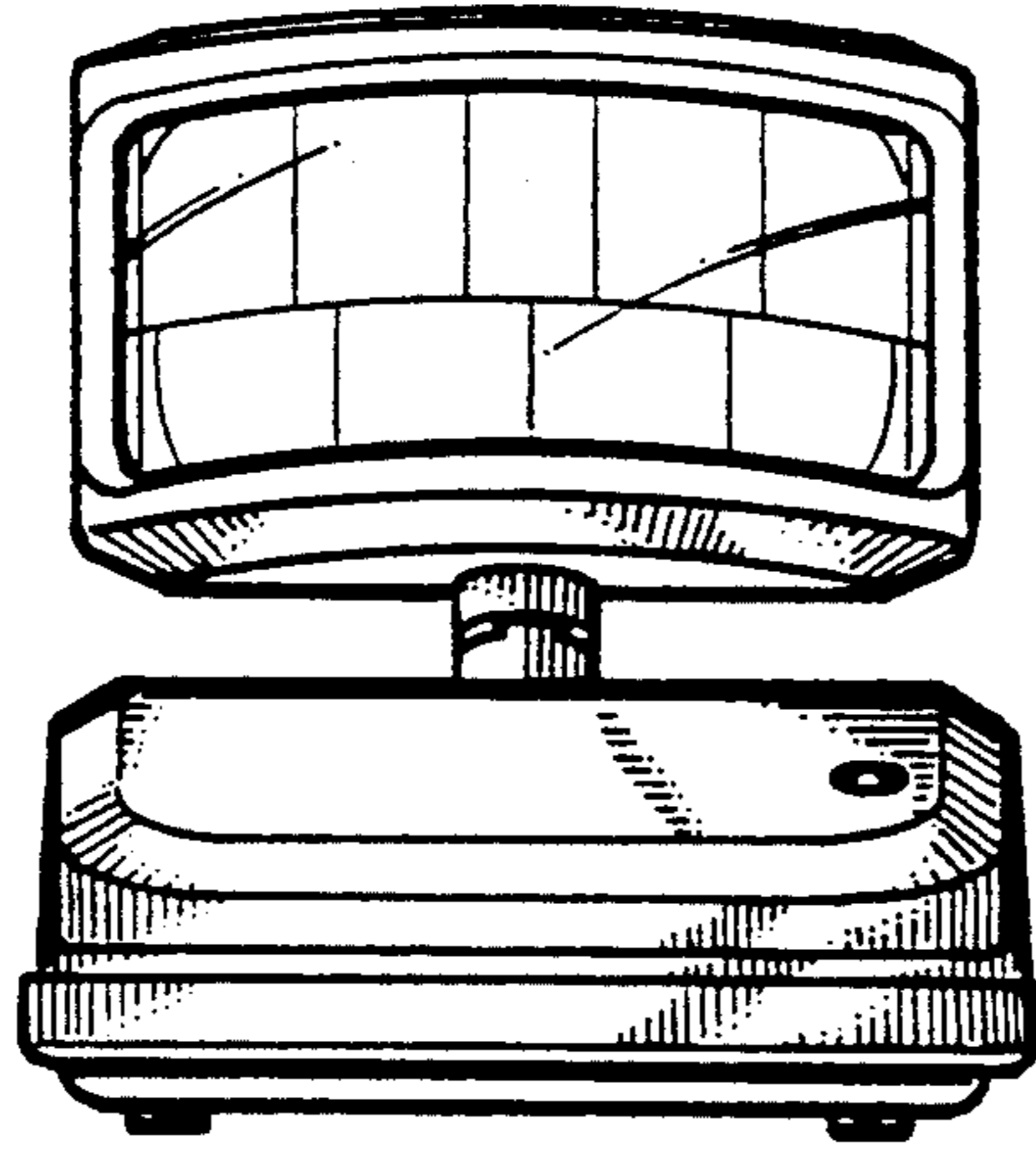
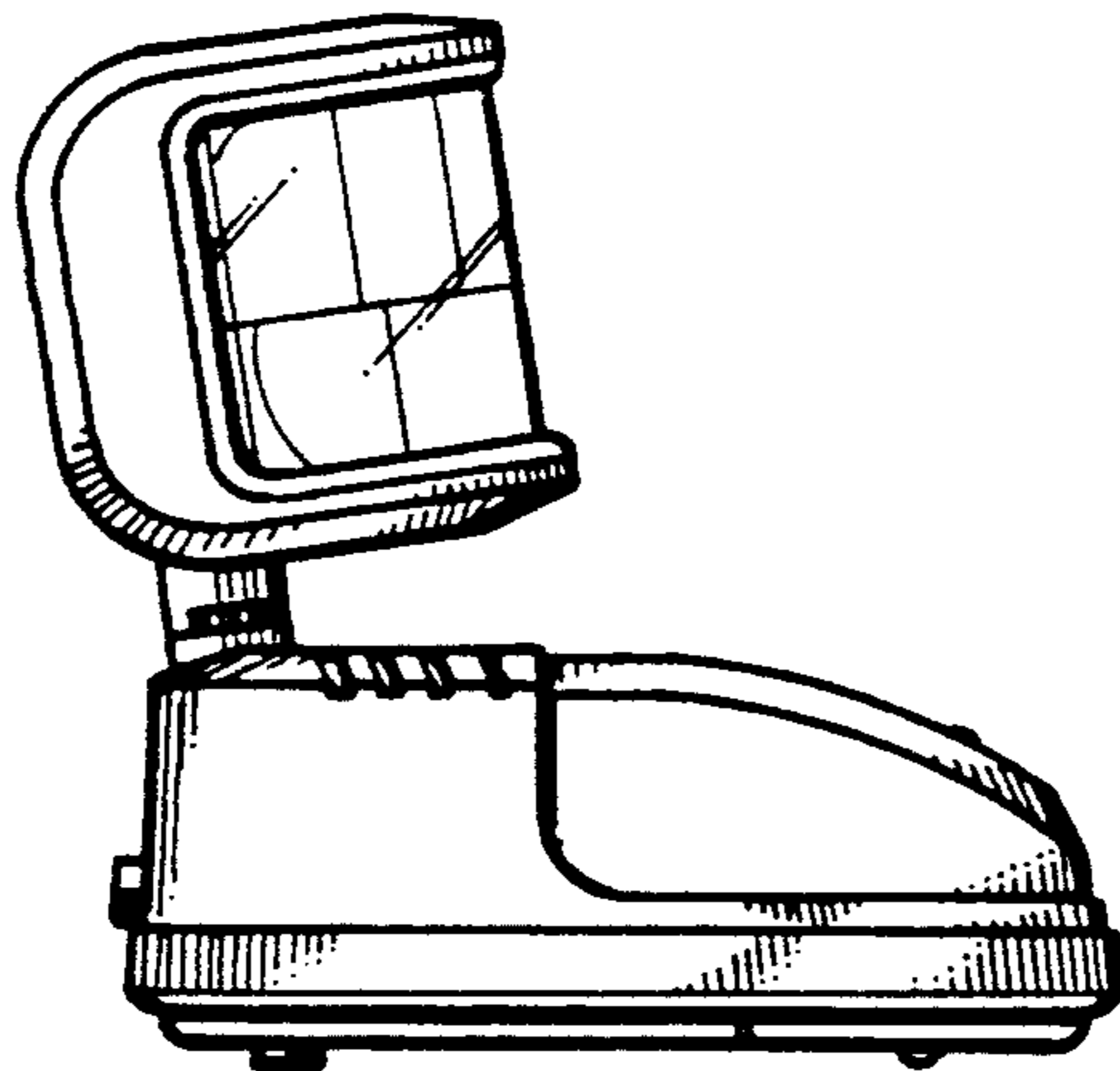


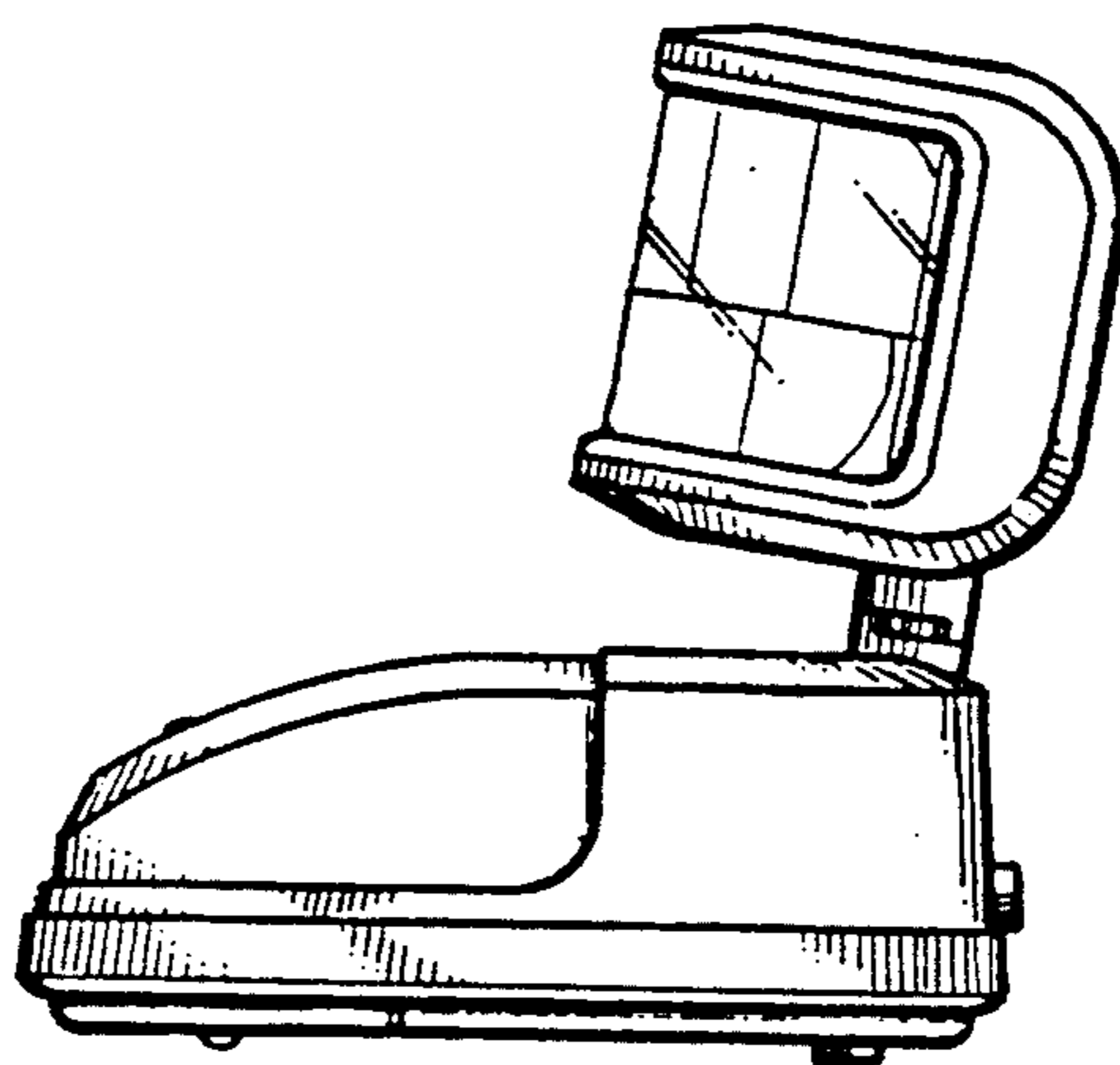
FIG. 1.



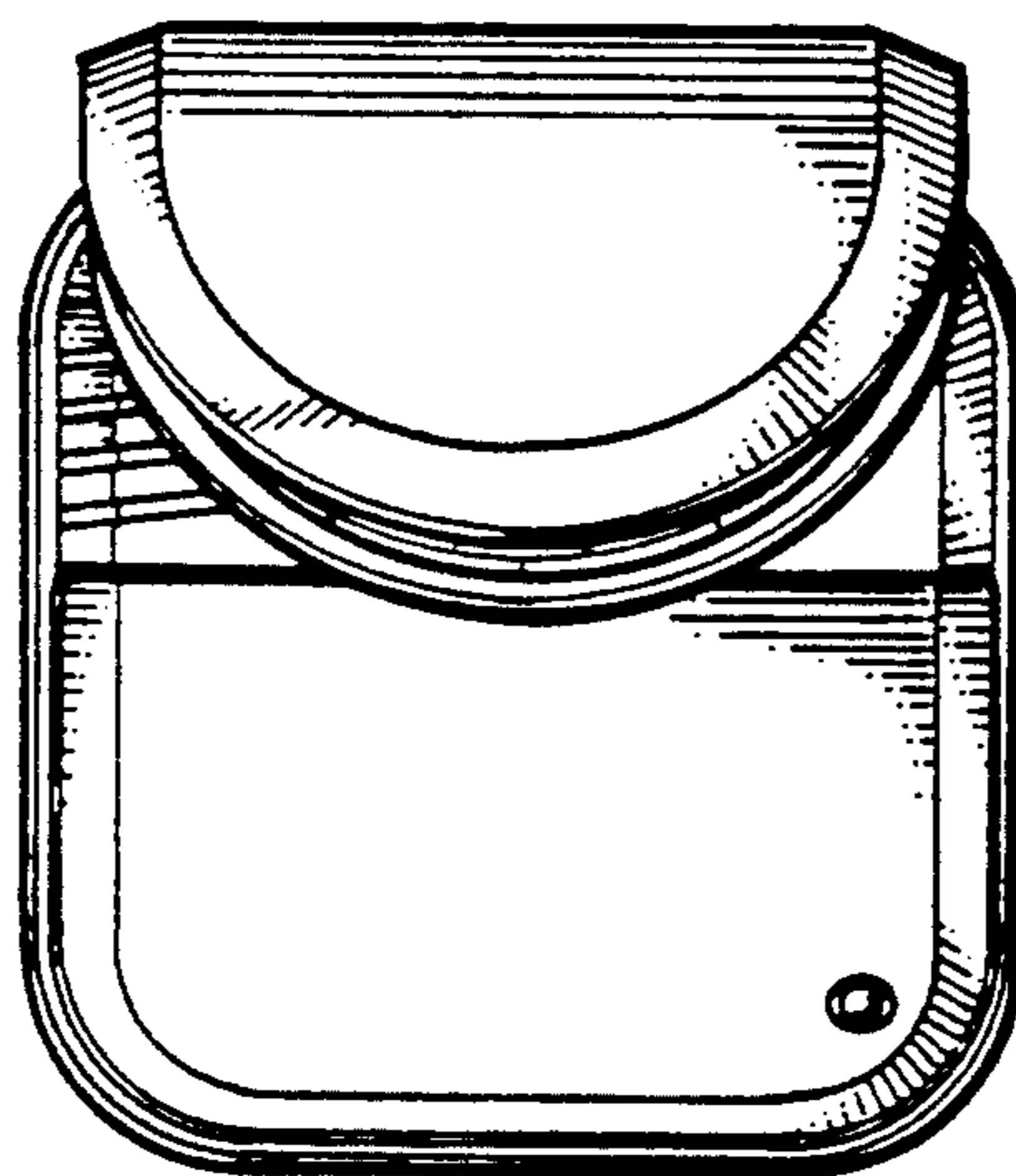
*FIG. 2.*



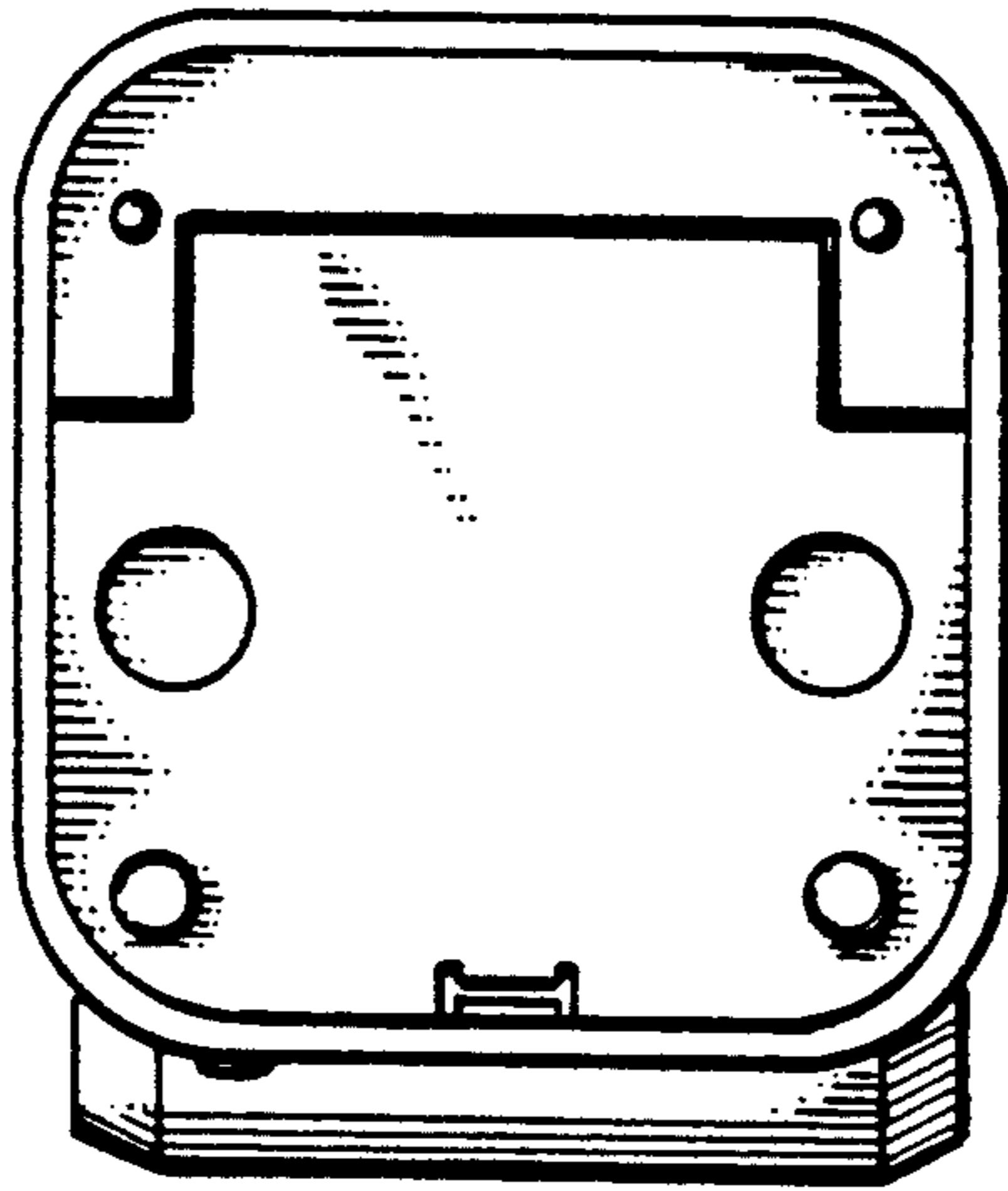
*FIG. 3.*



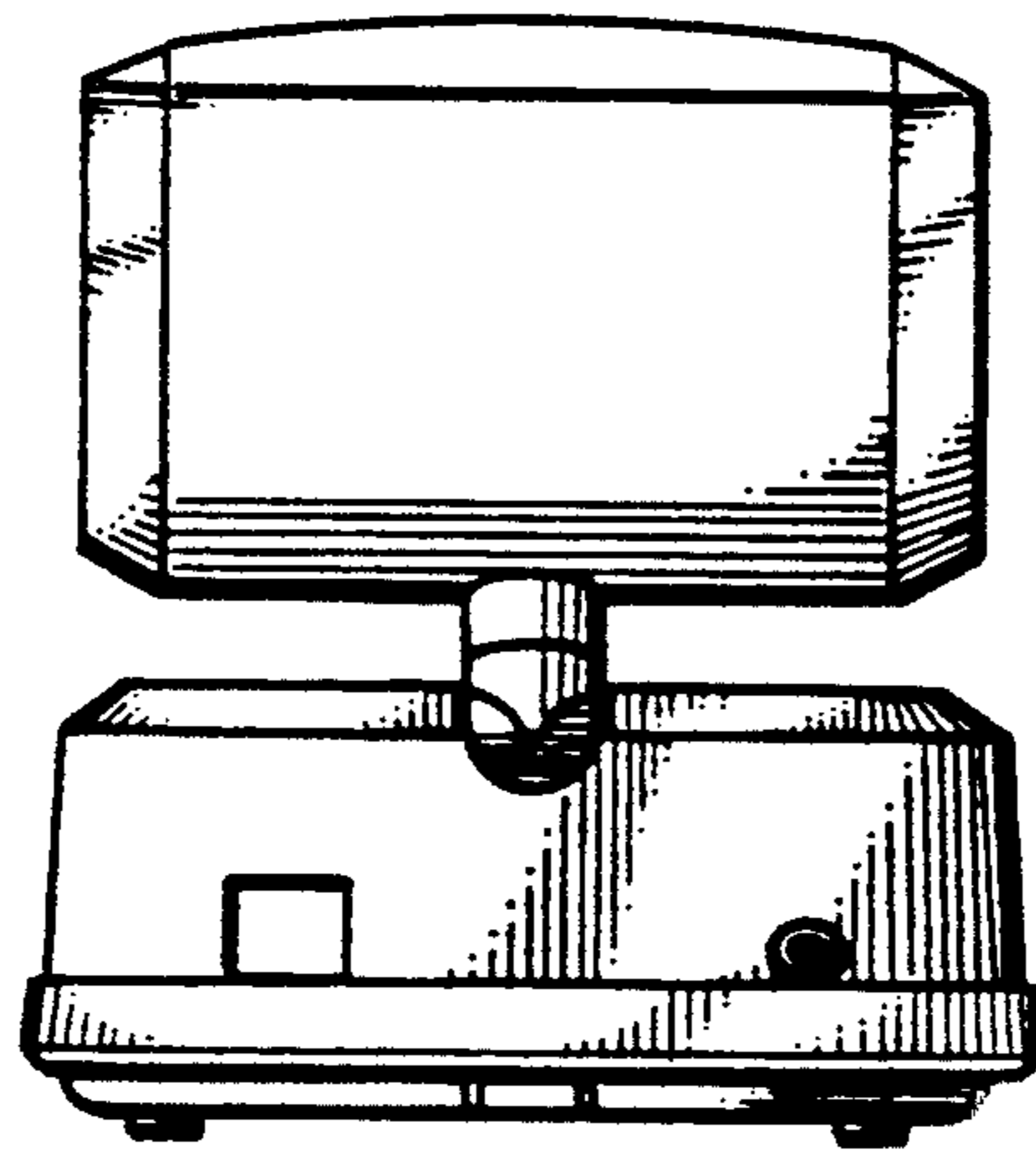
*FIG. 4.*



*FIG. 5.*



*FIG. 6.*



*FIG. 7.*